

Decomposition of CO₂ into CO and O in a Microwave-Excited Discharge Flow of CO₂/He or CO₂/Ar Mixtures

Masaharu Tsuji,* Takeshi Tanoue,[†] Kousuke Nakano,[†] and Yukio Nishimura

Institute of Advanced Material Study, Kyushu University, Kasuga, Fukuoka 816-8580

[†]*Department of Applied Science for Electronics and Materials, Graduate School of Engineering Sciences, Kyushu University, Kasuga, Fukuoka 816-8580*

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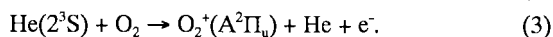
Decomposition of CO₂ in a fast electric discharge flow of CO₂/He or CO₂/Ar mixtures was studied by observing UV and visible emission spectra. The decomposition efficiency of CO₂ in CO₂/Ar mixtures was higher than that in CO₂/He mixtures. More than 90% of CO₂ in CO₂/Ar mixtures was selectively decomposed into CO and O at a microwave power of 100–200 W, and CO₂ and Ar flow rates of 25 and 1000 sccm, respectively, at a total pressure of 0.5 Torr.

Since CO₂ is a major source of the greenhouse effect, novel removal techniques are being developed to remove CO₂ from combustion gases. Various catalytic reduction processes, direct decomposition into C_n, CO, and O₂ in an electric discharge, and plasma-assisted catalytic systems have been proposed.^{1–3} If CO₂ can be decomposed without using catalysts, a convenient removal process can be developed. Here, we applied a fast electric discharge-flow system to the removal of CO₂ in CO₂/He or CO₂/Ar mixtures. The decomposition efficiency and the decomposition products of CO₂ were analyzed using UV and visible emission spectroscopy.

The discharge-flow apparatus used for the present study of the CO₂ removal was similar to that reported previously.⁴ It consisted of a stainless-steel main flow tube and two quartz discharge tubes. The discharge-flow apparatus was continuously evacuated using a 10 m³/min booster pump. CO₂ and He or Ar gases were kept at a constant mass flow rate and various mixtures of them were fed into a 2.45-GHz microwave discharge operated at an output power of 50–200 W. The flow rates of He and Ar were 2000 and 1000 sccm (standard cubic centimeter per minute), respectively. The partial pressures of CO₂, He, and Ar in CO₂/Ar or CO₂/He mixtures were 0.004–0.02, 0.1, and 0.06 Torr (1 Torr = 133.33 Pa), respectively, while that of He used for the generation of the lowest excited triplet He(1s2s:2³S) state was 0.4 Torr.

UV and visible emission spectra resulting from the He(2³S) reactions were used as a new method to monitor CO₂ and its discharge products. The metastable He(2³S) atoms with an available energy of 19.82 eV, and He⁺ and He₂⁺ ions were generated by a second microwave discharge of pure He gas in a quartz tube. He⁺ and He₂⁺ ions were prevented from entering the reaction zone by a pair of ion-collector grids placed on an exit opening of the discharge tube. The emission spectra resulting from the reactions of He(2³S) with CO₂ and its discharge products were dispersed in the 190–600 nm region with a Spex 1250 M monochromator equipped with a cooled Hamamatsu Photonics R376 photomultiplier. Photon signals from the photomultiplier were digitized using an AD converter and stored in a microcomputer.

Possible stable final gaseous products resulting from the decomposition of CO₂ are CO and O₂. It is known that Penning ionization of He(2³S) with CO₂, CO, and O₂ provides the following emitting excited species:^{5–7}



These processes could be monitored by observing CO₂⁺(A→X, B→X), CO⁺(A→X, B→X), and O₂⁺(A→X) emission systems in the 190–600 nm region. Here, X, A, and B denote the ground state and 1st and 2nd excited states of molecular ions, respectively.

Figure 1(a) shows a typical emission spectrum of a CO₂/He mixture obtained by switching off the microwave discharge. The spectrum is composed of CO₂⁺(A→X, B→X) emissions from process (1). By switching on the microwave discharge, the emission intensities of CO₂⁺(A→X, B→X) decrease, while CO⁺(A→X, B→X) emissions appear, as shown in Figure 1(b). No O₂⁺(A→X) emission was observed under the present experimental conditions, though it was detected by the addition of pure O₂ into the discharge flow. When the buffer He gas was replaced by Ar, similar emission spectra were observed.

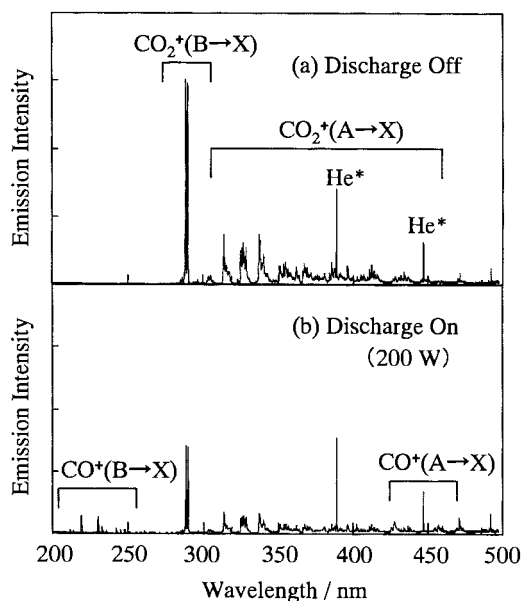


Figure 1. Emission spectra resulting from Penning ionization of He(2³S) with a CO₂/He mixture at a CO₂ flow rate of 100 sccm.

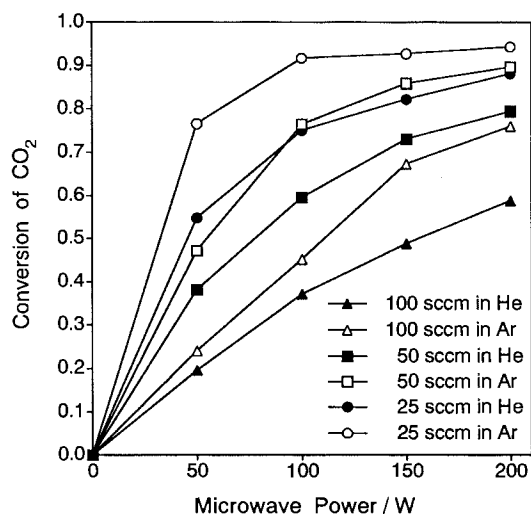
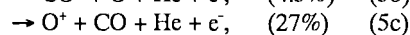
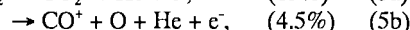


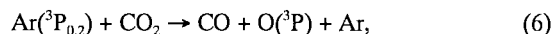
Figure 2. The dependence of conversion of CO₂ in CO₂/He and CO₂/Ar mixtures on the microwave power.

In order to examine the optimum decomposition conditions, the decomposition efficiency of CO₂ was measured as a function of the microwave power at CO₂ flow rates of 25, 50, and 100 sccm. The decomposition efficiency of CO₂ was determined from the reduction of the CO₂⁺(B→X) band, as shown in Figure 1. Figure 2 shows the dependence of the conversion of CO₂ on the microwave power in CO₂/He and CO₂/Ar mixtures. With increasing microwave power from 0 to 200 W, the conversion of CO₂ increases. The conversion of CO₂ increases with decreasing the CO₂ flow rate from 100 to 25 sccm in both CO₂/He and CO₂/Ar mixtures. It should be noted that CO₂ in CO₂/Ar mixtures is decomposed more efficiently than that in CO₂/He mixtures, even though the Ar flow rate is a half of the He flow rate. It is clear from Figure 2 that more than 90% of CO₂ is decomposed at microwave power of 100–200 W in CO₂/Ar mixtures at the lowest CO₂ flow rate of 25 sccm.

In the microwave discharge of CO₂/He and CO₂/Ar mixtures, the following electron-impact dissociation and ionization (4a)–(4c), Penning ionization (5a)–(5c), and dissociation process (6), dominantly occur at first, leading to CO, O, CO₂⁺, CO⁺, and O⁺:



$$k_5(\text{total}) = 6.0 \times 10^{-10} \text{ cm}^3 \text{ molecule}^{-1} \text{ s}^{-1} \text{ [ref 8,9]},$$



$$k_6 = 5.9(^3\text{P}_0) \text{ and } 5.3(^3\text{P}_2) \times 10^{-10} \text{ cm}^3 \text{ molecule}^{-1} \text{ s}^{-1} \text{ [ref 10, 11]}.$$

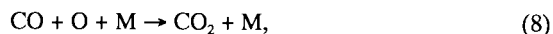
Subsequent electron-ion recombination process (7) will take place in the discharge and downflow region:



$$k_7 = 3.8 \times 10^{-7} \text{ cm}^3 \text{ s}^{-1} \text{ [ref 12]}.$$

In addition, the following three-body recombination processes

may take place:



$$k_8 = 6.6 \times 10^{-33} \exp(-2173/T) \text{ cm}^6 \text{ molecule}^{-2} \text{ s}^{-1} \text{ [ref 13]},$$



$$k_9 = 2.76 \times 10^{-31}/T \text{ cm}^6 \text{ molecule}^{-2} \text{ s}^{-1} \text{ [ref 13]},$$

where M stands for third-body CO₂, He, or Ar. Two-body rate constants of the above three-body recombination reactions (8) and (9) at an M pressure of 0.5 Torr and 300 K were calculated to be 7.6×10^{-20} and $1.5 \times 10^{-17} \text{ cm}^3 \text{ molecule}^{-1} \text{ s}^{-1}$, respectively, from the relation $k_x[\text{M}]$ for $x = 8$ and 9 . Since these values are much smaller than k_5 – k_7 , three-body processes (8) and (9) will be insignificant under the present experimental conditions. A higher decomposition efficiency of CO₂ into CO + O in CO₂/Ar mixtures than that in CO₂/He mixtures is probably due to the fact that dissociation process (6) is a fast direct decomposition process of CO₂ into CO + O in CO₂/Ar mixtures, while a sufficient amount of slow electrons is required for the formation of CO + O via process (7) in CO₂/He mixtures.

The lack of the O₂⁺(A→X) emission indicated that O₂ concentration in the observation of emission spectra was too low to detect the O₂⁺(A→X) emission because a high buffer gas pressure was required for the formation of O₂ from three-body process (9).

In conclusion, CO₂ could be efficiently decomposed by a microwave discharge of CO₂/He or CO₂/Ar mixtures. A cheaper Ar was found to be more effective for the preferential decomposition of CO₂ into CO + O at a low CO₂ flow rate of 25 sccm. The He(2³S) reactions could be used as a new technique for monitoring the decomposition process of CO₂ in a discharge flow of CO₂/He or CO₂/Ar mixtures. We are planning further study of the decomposition of CO₂ in the presence of N₂, O₂, and H₂O at higher pressures for the practical application of this technique to CO₂ removal from combustion gases.

References and Notes

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